



SAF/2227

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829  
Examiner: J. Hollington

#  
12  
4-17-03  
J. Hollington

In Re PATENT APPLICATION Of:

Applicant(s) : Mikio OHTAKI

Serial No. : 09/904,663

Filed : July 16, 2001

For : METHOD FOR MANUFACTURING  
AND BATCH TESTING  
SEMICONDUCTOR DEVICES

Attorney Ref. : KAN 120D1

PETITION FOR  
ONE-MONTH  
EXTENSION OF TIME

Commissioner for Patents  
Washington, D.C. 20231  
**BOX - AF**

RECEIVED  
APR 10 2003  
2829

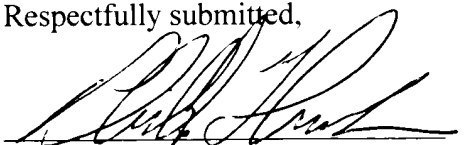
Sir:

It is respectfully requested that the period for replying to the Examiner's Action dated December 10, 2002, be extended for one month under the provisions of 37 C.F.R. 1.136(a).

The applicable extension fee of \$110.00 pursuant to 37 C.F.R. 1.17(a) is submitted herewith.

Should any additional fees be required, please charge the same to our Deposit Account No. 18-0002 and advise us accordingly.

Respectfully submitted,

  
Phillip G. Avruch - Reg. No. 46,076  
RABIN & BERDO, P.C.  
Telephone: 202-371-8976  
Telefax: 202-408-0924  
CUSTOMER NO. 23995

April 10, 2003  
Date

PGA:tlc

FEE ENCLOSED: \$ 112.00  
Please charge any further  
fee to our Deposit Account  
No. 18-0002